Examiner-Initiated Interview Summary	Application No.	Applicant(s)
	10/710,855	CHANG, SUNG-SAN
	Examiner	Art Unit
	HENOK G. HEYI	2627
Participants: Status of Application: <u>pending</u>		
(1) <u>HENOK G. HEYI</u> .	(3)	
(2) <u>Scott Margo</u> .	(4)	
Date of Interview: <u>10 July 2008</u>	Time: <u>3PM</u>	
Type of Interview:		
Part I.		
Rejection(s) discussed: Canceling of claim 8 and allowance of claims 1-7		
Claims discussed: Claim 8		
Prior art documents discussed: None		
Part II.		
SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED: Scott Margo, on behalf of Winston Hsu, agrred to camcel claim 8 so that the application would be in condition for allowance.		
Part III.		
<ul> <li>It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability.</li> <li>It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.</li> </ul>		
/Henok G Heyi/ Examiner, Art Unit 2627  (Applicant/Applicant's Representative Signature – if appropriate)		

U.S. Patent and Trademark Office PTOL-413B (04-03)